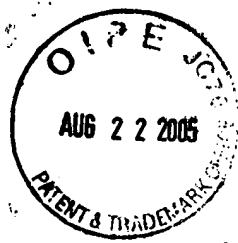


IFW



PATENT
Customer No. 22,852
Attorney Docket No. 03180.0338

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Masao Iwase et al.)	Group Art Unit: 2811
)	
Serial No.: 10/687,705)	Examiner: Sara W. Crane
)	
Filed: October 20, 2003)	
)	Confirmation No.: 2832
For: SEMICONDUCTOR WAFER AND)	
A METHOD FOR)	
MANUFACTURING A)	
SEMICONDUCTOR WAFER)	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed May 20, 2005, the period for response to which extends through August 22, 2005 (August 20 being a Saturday), please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks follow the **Amendment to the Claims** section and begins on page 5 of this paper.